

OFFICIAL**RECEIVED
CENTRAL FAX CENTER****IN THE UNITED STATES PATENT AND TRADEMARK OFFICE****AUG 17 2004****Applicant(s): Vishwanathan et al.****Application No.: 09/608,537****Filed: 6/30/2000****Title: POLISHING PADS FOR CHEMICAL
MECHANICAL PLANARIZATION****Attorney Docket No.: 126****Commissioner for Patents
Alexandria, VA 22313-1450****Group Art Unit:
3724****Examiner:
T. Eley****AMENDMENT****Dear Sir:**

In response to the action dated June 7, 2004, kindly enter the terminal disclaimer and
amend the specification as follows: